



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Hyoung June KIM)	Examiner: Quang T. Van
Serial No.:	09/886,940)	Art Unit: 3742
Filed:	June 21, 2001)	Our Ref: B-4227 618899-5/MSG/RP
For:	METHODS & APPARATUSES FOR HEAT TREATMENT OF SEMICONDUCTOR FILMS UPON THERMALLY SUSCEPTIBLE NON- CONDUCTING SUBSTRATES)	Date: May 25, 2004
)	Re: <i>Request for Continued Examination</i>

AMENDMENT AND RESPONSE

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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JUN 03 2004

TECHNOLOGY CENTER R3700

Sir:

In reply to the final Office Action mailed on February 25, 2004, an initial response to which is due no later than **May 25, 2004**, Applicant submits this paper together with a Request for Continued Examination (RCE) pursuant to 37 C.F.R. 1.114 and a check in the amount of \$385.00 for the fee set forth in 37 C.F.R. 1.17(e). Please amend the above-identified application as described below and consider the following remarks. **All amendments and remarks herein are made without prejudice.**

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.